

<b>Information Disclosure Citation in an Application</b>	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

**U.S. PATENT DOCUMENTS**

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
/JJF/	2,278,838	04/07/42	Groote et al.			03/11/40
	2,670,329	02/23/54	Jones			08/03/50
	2,689,244	09/14/54	Jones			06/23/50
	2,819,278	01/07/58	De Groot et al.			05/09/56
	2,877,179	03/10/59	Hughes et al.			03/26/56
	3,008,898	11/14/61	Hughes et al.			06/26/59
	3,052,298	09/04/62	Mallot			03/22/60
	3,065,247	11/10/62	De Groot et al.			11/23/55
	3,326,890	06/20/67	Engelskirchen et al			12/18/64
	3,336,980	08/22/67	Rike			02/09/67
	3,489,222	01/13/70	Millhone et al.			12/26/68
	3,601,194	08/24/71	Gallus			07/14/69
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	3,902,557	09/02/75	Shaughnessy, et al.			03/25/74
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	5,424,284	06/13/95	Patel et al.			07/02/93
/JJF/	5,445,223	08/29/95	Nelson, et al.			03/15/94

<b>EXAMINER</b> /John J. Figueroa/	<b>DATE CONSIDERED</b> 03/16/2008
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/JJF/	5,597,783	01/28/97	Audibert, et al			05/04/95
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	5,643,460	07/01/97	Marble, et al.			06/30/95
	5,681,796	10/28/97	Nimerick			07/29/94
	5,704,426	01/06/98	Rytlewski, et al.			03/20/96
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	6,209,646	04/03/01	Reddy, et al			04/21/99
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/JJF/	7,220,708	05/22/07	Zamora, et al			02/27/03

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### NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	
/JJF/	Office action dated 12/28/2007 from application serial number 10/806,894	12/28/2007
	Office action dated 7/12/2007 from application serial number 10/806,894	7/12/2007
	Office action dated 4/9/2007 from application serial number 10/806,894	4/9/2007
	Office action dated 1/3/2007 from application serial number 10/806,894	1/3/2007
	Office action dated 7/3/2006 from application serial number 10/806,894	7/3/2006
	Notice of allowance dated 1/28/2008 from application serial number 11/102,062	1/28/2008
	Office action dated 6/27/2007 from application serial number 11/102,062	6/27/2007
	Office action dated 5/1/2007 from application serial number 11/122,836	5/1/2007
	Office action dated 11/14/2007 from application serial number 11/122,836	11/14/2007
	Office action dated 2/1/2008 from application serial number 10/440,337	2/1/2008
	Office action dated 11/15/2006 from application serial number 10/440,337	11/15/2006
	Office action dated 5/3/2006 from application serial number 10/440,337	5/3/2006
	Notice of allowance dated 3/23/2006 from application serial number 10/236,722	3/23/2006
	Office action dated 9/28/2005 from application serial number 10/236,722	9/28/2005
	Office action dated 7/5/2005 from application serial number 10/236,722	7/5/2005
	Office action dated 4/19/2005 from application serial number 10/236,722	4/19/2005
	Office action dated 10/20/2004 from application serial number 10/236,722	10/20/2004
	Notice of allowance dated 3/23/2006 from application serial number 10/612,271	3/23/2006
	Notice of allowance dated 7/18/2006 from application serial number 10/825,001	7/18/2006
	Office action dated 1/6/2006 from application serial number 10/825,001	1/6/2006
	Notice of allowance dated 8/17/2006 from application serial number 10/881,198	8/17/2006
	Notice of allowance dated 5/25/2006 from application serial number 10/881,198	5/25/2006
	Notice of allowance dated 3/5/2007 from application serial number 10/893,210	3/5/2007
	Notice of allowance dated 2/27/2007 from application serial number 10/893,210	2/27/2007
↓	Office action dated 9/12/2006 from application serial number 10/893,210	9/12/2006
/JJF/	Office action dated 1/14/2008 from application serial number 11/471,148	1/14/2008

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		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	
	/JJF/	Office action dated 11/2/2007 from application serial number 11/471,148	11/2/2007
		Office action dated 9/20/2007 from application serial number 11/471,148	9/20/2007
		Office action dated 4/5/2007 from application serial number 11/471,148	4/5/2007
		Office action dated 1/14/2008 from application serial number 11/471,738	1/14/2008
		Office action dated 11/2/2007 from application serial number 11/471,738	11/2/2007
		Office action dated 9/20/2007 from application serial number 11/471,738	9/20/2007
		Office action dated 4/6/2007 from application serial number 11/471,738	4/6/2007
		Office action dated 9/24/2007 from application serial number 10/862,132	9/24/2007
		Office action dated 7/12/2007 from application serial number 10/862,132	7/12/2007
		Office action dated 1/22/2007 from application serial number 10/862,132	1/22/2007
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	/JJF/	Proett, et al., <i>Advanced Dual Probe Formation Tester with Transient, Harmonic, and Pulsed Time-Delay Testing Methods Determines Permeability, Skin, and Anisotropy</i> , SPE 64650, 2000, Society of Petroleum Engineers Inc., presented at the SPE International Oil and Gas Conference and Exhibition in China held in Beijing, China, November 7-10, 2000	11/7/00
	/JJF/	Proett, et al., <i>Advanced Permeability and Anisotropy Measurements While Testing and Sampling in Real-time Using a Dual Probe Formation Tester</i> , SPE 62919, 2000, Society of Petroleum Engineers Inc., presented at the 2000 SPE Annual Technical Conference and Exhibition held in Dallas, Texas, October 1-4, 2000	10/1/00
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	/JJF/	Xu, et al., <i>Modeling of Laser Spallation Drilling of Rocks for Gas--and Oilwell Drilling</i> , SPE 95746, 2005, Society of Petroleum Engineers Inc., presented at the 2005 SPE Annual Technical Conference and Exhibition held in Dallas, Texas, October 9-12, 2005	10/9/03
	/JJF/	Batareseh, et al., <i>Well Perforation Using High-Power Lasers</i> , SPE 84418, 2003, Society of Petroleum Engineers Inc., presented at the SPE Annual Technical Conference and Exhibition held in Denver, Colorado, October 5-8, 2003	10/5/03

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